

L Number	Hits	Search Text	DB	Time stamp
1	23	(ryoichi same mukai).in.	USPAT	2003/09/29 11:12
-	8	sputter\$3 with ((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide))) with platinum with cobalt	USPAT	2003/09/26 13:37
-	8	((sputter\$3 with ((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide))) with platinum) and magnetic\$3	USPAT	2003/09/26 13:36
-	12	((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide))) with platinum with cobalt same sputter\$3	USPAT	2003/09/26 14:04
-	161	((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide))) with platinum with cobalt	USPAT	2003/09/26 14:04
-	51	((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide))) with platinum with cobalt and sputter\$3	USPAT	2003/09/26 14:04
-	39	((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide))) with platinum with cobalt and sputter\$3 xor (((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide))) with platinum with cobalt same sputter\$3)	USPAT	2003/09/26 14:04
-	64	sputter\$3 with ((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide))) with platinum	USPAT	2003/09/26 14:32
-	0	((dual or two or multiple) adj cathode) with ((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide))) with platinum	USPAT	2003/09/26 14:13
-	0	((dual or two or multiple) adj cathode) with ((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide)))	USPAT	2003/09/26 14:14
-	0	((dual or two or multiple) near2 cathode) with ((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide)))	USPAT	2003/09/26 14:14
-	14	((dual or two or multiple) near2 cathode) same ((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide)))	USPAT	2003/09/26 14:18
-	1	((dual or two or multiple) near2 cathode) and ((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide)))with platinum	USPAT	2003/09/26 14:18
-	1	((dual or two or multiple) near2 cathode) and ((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide))) with platinum	USPAT	2003/09/26 14:18
-	3	((dual or two or multiple) near2 cathode) and ((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide))) same platinum	USPAT	2003/09/26 14:21
-	76	sputter\$3 and ((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide))) near2 platinum	USPAT	2003/09/26 14:21
-	11	sputter\$3 same ((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide))) near2 platinum	USPAT	2003/09/26 14:23
-	1930	sputter\$3 with metal near2 (oxide or nitride)	USPAT	2003/09/26 14:23

-	0	sputter\$3 with metal near2 "with" with (oxide or nitride)	USPAT	2003/09/26 14:23
-	0	sputter\$3 with metal near2 "with" near2 (oxide or nitride)	USPAT	2003/09/26 14:23
-	0	sputter\$3 with metal near2 "with" near2 (oxide or nitride)	USPAT	2003/09/26 14:24
-	0	sputter\$3 with metal with "with" with (oxide or nitride)	USPAT	2003/09/26 14:28
-	4469	sputter\$3 with metal with (oxide or nitride)	USPAT	2003/09/26 14:28
-	2312	sputter\$3 with metal near2 (oxide or nitride)	USPAT	2003/09/26 14:28
-	0	sputter\$3 with metal near2 (oxide or nitride) with ((dual or multiple or two) near2 cathode)	USPAT	2003/09/26 14:32
-	88	dual adj cathode	USPAT	2003/09/26 14:32
-	4	((dual adj cathode) and ((silicon adj nitride) or (silicon adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide))) and platinum	USPAT	2003/09/26 14:37
-	270	((silicon adj nitride) or (silicon adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide))) near2 platinum	USPAT	2003/09/26 14:38
-	76	((silicon adj nitride) or (silicon adj (oxide or dioxide)) or (aluminum adj (oxide or dioxide))) near2 platinum and sputter\$3	USPAT	2003/09/26 15:01
-	1044	cermet with (silicon adj (oxide or dioxide or nitride)) or (aluminum adj (oxide or dioxide)) with platinum	USPAT	2003/09/26 14:48
-	223	cermet with (silicon adj (oxide or dioxide or nitride)) or (aluminum adj (oxide or dioxide)) near2 platinum	USPAT	2003/09/26 14:49
-	4	cermet with (silicon adj (oxide or dioxide or nitride)) or (aluminum adj (oxide or dioxide)) near2 platinum same sputter\$3	USPAT	2003/09/26 14:50
-	67	cermet with (silicon adj (oxide or dioxide or nitride)) or (aluminum adj (oxide or dioxide)) near2 metal same sputter\$3	USPAT	2003/09/26 14:51
-	88	(silicon adj (oxide or dioxide or nitride)) or (aluminum adj (oxide or dioxide)) near2 metal same sputter\$3	USPAT	2003/09/26 14:51
-	67	cermet with (silicon adj (oxide or dioxide or nitride)) or (aluminum adj (oxide or dioxide)) near2 metal same sputter\$3	USPAT	2003/09/26 14:52
-	1	5227193.pn.	USPAT	2003/09/26 15:01
-	1	5227193.pn. and platinum	USPAT	2003/09/26 15:04
-	1	5227193.pn. and prevent\$3	USPAT	2003/09/26 15:05
-	1	5227193.pn. and sputtering	USPAT	2003/09/26 15:07
-	1	5846648.pn.	USPAT	2003/09/26 15:07
-	1	6183606.pn.	USPAT	2003/09/26 15:07
-	1	6242085.pn.	USPAT	2003/09/26 15:07
-	3	5846648.pn. or 6183606.pn. or 6242085.pn.	USPAT	2003/09/26 15:07
-	1	6242085.pn.	USPAT	2003/09/29 09:51
-	0	6242085.pn. and crystalline	USPAT	2003/09/29 09:51
-	0	6242085.pn. and crystalline\$4	USPAT	2003/09/29 09:51
-	0	6242085.pn. and crystalline\$4	USPAT	2003/09/29 09:51
-	1	6242085.pn. and crystal	USPAT	2003/09/29 11:11